



presents

Nikolay S. Makarov

the

2007 BACUS Photomask Scholarship

Sponsored by BACUS, SPIE's Photomask International technical Group

In recognition of his achievement in the field of microlithography.



A handwritten signature in black ink, appearing to read 'Tom Cahill', written over a horizontal line.

SPIE President

August 28, 2007

Date